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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **HAYASHI, Nobuhiko**

Group Art Unit: 2828

Serial No.: **09/532,786**

Examiner: **Armando RODRIGUEZ**

Filed: **March 22, 2000**

P.T.O. Confirmation No.: **8588**

FOR: **SEMICONDUCTOR LASER DEVICE AND METHOD OF FABRICATING THE SAME**

**RESPONSE UNDER 37 CFR §1.116**

**- EXPEDITED RESPONSE -**

**GROUP ART UNIT 2828**

**MAILSTOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 27, 2005

Sir:

In response to the Office Action dated August 8, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.